



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takatoshi TSUCHIYA et al.

Application No.: 10/721,353

Group Art Unit: 2853

Filed: November 26, 2003

Docket No.: 117059

For: SYSTEMS AND METHODS FOR VENT PATH LEAKAGE PREVENTION

SUBMISSION OF ORIGINAL DECLARATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith is the original signed Declaration of the Inventors. This Declaration corresponds to the facsimile copy of the Declaration filed on November 26, 2003.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Gerhard W. Thielman
Registration No. 43,186

JAO:GWT/tbh

Date: May 26, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400